

**IN THE U.S. PATENT AND TRADEMARK OFFICE**

Application No.: 10/519,700 )  
Filing Date: September 14, 2005 )  
Inventor(s): Krull )  
Group Art Unit: 1765 )  
Examiner Name: Angadi,Maki A )  
Customer No.: 27160 )  
Confirmation No.: 6925 )  
Title: ION IMPLANTATION ION )  
SOURCE, SYSTEM AND METHOD )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the Official Action, mailed on August 6, 2007, please enter the following preliminary amendment.

**Amendments to the Specification** are reflected on page 2 of this paper.

**Remarks** begin on page 8 of this paper.